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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
09/879,934	06/14/2001	Yasumi Sago	K-1984	4444
32628	7590 11/07/2005	EXAMINER		
	BERNER AND PA	KACKAR, RAM N		
	SUITE 300, 1700 DIAGONAL RD ALEXANDRIA, VA 22314-2848		ART UNIT	PAPER NUMBER
712274	,	•	1763	
			DATE MAILED: 11/07/2005	

Please find below and/or attached an Office communication concerning this application or proceeding.

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	Application No.	Applicant(s)			
	09/879,934	SAGO ET AL.			
Office Action Summary	Examiner	Art Unit			
	Ram N. Kackar	1763			
The MAILING DATE of this communication ap Period for Reply	ppears on the cover sheet with the o	correspondence address			
A SHORTENED STATUTORY PERIOD FOR REPL WHICHEVER IS LONGER, FROM THE MAILING I - Extensions of time may be available under the provisions of 37 CFR 1 after SIX (6) MONTHS from the mailing date of this communication. - If NO period for reply is specified above, the maximum statutory period - Failure to reply within the set or extended period for reply will, by statu Any reply received by the Office later than three months after the maili earned patent term adjustment. See 37 CFR 1.704(b).	DATE OF THIS COMMUNICATION .136(a). In no event, however, may a reply be tired will apply and will expire SIX (6) MONTHS from the cause the application to become ABANDONE	N. nely filed the mailing date of this communication. (D) (35 U.S.C. § 133).			
Status		,			
1) Responsive to communication(s) filed on 04 A	<u> August 2005</u> .				
2a) This action is FINAL . 2b) This action is non-final.					
3) Since this application is in condition for allowance except for formal matters, prosecution as to the merits is					
closed in accordance with the practice under	Ex parte Quayle, 1935 C.D. 11, 49	53 O.G. 213.			
Disposition of Claims					
4)	awn from consideration.				
Application Papers					
9)☐ The specification is objected to by the Examin	er				
10) The drawing(s) filed on is/are: a) ac		Examiner			
Applicant may not request that any objection to the					
Replacement drawing sheet(s) including the correct					
11)☐ The oath or declaration is objected to by the E	xaminer. Note the attached Office	Action or form PTO-152.			
Priority under 35 U.S.C. § 119					
 12) Acknowledgment is made of a claim for foreign a) All b) Some * c) None of: 1. Certified copies of the priority document 2. Certified copies of the priority document 3. Copies of the certified copies of the priority document application from the International Bureat * See the attached detailed Office action for a list 	ats have been received. ats have been received in Applicationity documents have been received au (PCT Rule 17.2(a)).	on No ed in this National Stage			
Attachment(s) 1) Notice of References Cited (PTO-892) 2) Notice of Draftsperson's Patent Drawing Review (PTO-948) 3) Information Disclosure Statement(s) (PTO-1449 or PTO/SB/08 Paper No(s)/Mail Date	4) Interview Summary Paper No(s)/Mail Da 5) Notice of Informal P 6) Other:				
S. Patent and Trademark Office PTOL-326 (Rev. 7-05) Office A	Action Summary	Part of Paper No./Mail Date 1005			

Application/Control Number: 09/879,934 Page 2

Art Unit: 1763

DETAILED ACTION

Continued Examination Under 37 CFR 1.114

1. A request for continued examination under 37 CFR 1.114, including the fee set forth in 37 CFR 1.17(e), was filed in this application after final rejection. Since this application is eligible for continued examination under 37 CFR 1.114, and the fee set forth in 37 CFR 1.17(e) has been timely paid, the finality of the previous Office action has been withdrawn pursuant to 37 CFR 1.114. Applicant's submission filed on 8/4/2005 has been entered.

Claim Rejections - 35 USC § 103

- 2. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
 - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 3. Claims 33, 34, 41-43, 48-49 and 56-58 are rejected under 35 U.S.C. 103(a) as being unpatentable over Mountsier et al (US 5810933) in view of Moslehi (US 5936829) and further in view of Sexton et al (US 6377437).

Mountsier et al disclose an electrostatic chuck (Fig 1 and Col 1 lines 39-54), comprising a dielectric layer (Fig 1-4), chucking electrode (Fig 1-2), temperature control (Col 1 line 41 and Col 8 lines 40-49), chucking power source (Fig 1-14), marginal convex (Fig 11b-78), chucking surface concaves for heat exchange gas (Fig 11b), under pressure (Col 7 line 48), gas distribution concave (Fig 11b –74) which are deeper than heat exchange concaves (Fig 11b), gas distribution concaves formed in coaxial with the center of the stage (Fig 7), gas inlets connected to gas

Art Unit: 1763

diffusion concaves at positions off the center of the stage (Fig 19a- 82 and Col 13 lines 50-60), the depth of heat exchange concaves being below 40 µm (Col 10 line 65) and the depth of gas diffusion concaves being 700 µm (Col 13 line 14), the contact area being 10% (Col 9 line 42), main body cooling cavity (Fig 3) and a heat conducting layer between dielectric and main body for cooling (Fig 5-54).

Area of gas diffusion concaves is indirectly disclosed to be at least 5% (on a wafer of 200 mm diameter (Col 11 line 37) and diffusion concave width of 0.5 to 2.5 mm (Col 13 line 16) and plan view of Fig 15a to 19 b will yield an estimate of at least 5%).

Mountsier et al disclose radial and circumferential gas diffusion concaves inside an outer circumferential concave, an inner circumferential concave (Fig 17a and 19a – the hexagonal shaped) and several alternative gas distribution structures, but do not explicitly disclose a plurality of inner circumferential concaves.

Moslehi discloses another chuck and discloses a plurality of circumferential concaves (Fig 3) containing gas inlet connected at the crossing of circumferential and radial concave (Fig 3-74).

Since additional inner circumferential concaves is an alternative and equivalent way for distributing heat transfer gas and helps in obtaining better uniformity closer to center as disclosed by Moslehi too, it would have been obvious for one of ordinary skill in the art at the time of invention to have additional circumferential concaves.

Mountsier et al as modified by Moslehi do not disclose lift pin provided in gas introduction channel.

Sexton et al disclose cooling gas flowing through lift pin holes (Abstract and Fig 9-46).

Art Unit: 1763

Therefore it would have been obvious for one with ordinary skill in the art at the time invention was made to use gas channel hole for dual purpose of lift pin hole as well as cooling gas channel to make the design simpler and economical.

Response to Amendment

Applicant's arguments filed 8/4/2005 have been fully considered but they are not persuasive.

Applicant argues that the three features of the claim 33 namely (a) radial concaves extending from the center of the stage, (b) all of the gas introducing channels communicate with the gas-diffusion concaves at positions off the center of the stage, and (c) each lift pin is disposed in each gas introducing channel have not been evaluated properly. Applicant argues further that no reference discloses all the three features.

In response it is noted that features (a) is disclosed by Mountsier et al and both (a) and (b) are disclosed by Moslehi while feature (c) being disclosed by Sexton et al. Thus a combination of references is relied upon for their individual teachings.

It has been held that unobviousness cannot be established by attacking the references individually when the rejection is based on a combination of references. *In re Novak* 16 USPQ 2d 2041, 2043 (Fed. Cir., BPAI 1989); *EWP Corp. v. Reliance Universal Inc.* 225 USPQ 20 (Fed. Cir. 1985); *In re Keller* 208 USPQ 871 (CCPA 1981); *Ex parte Varga* 189 USPQ 204 (PO BdPatApp 1973); *Ex parte Campbell* 172 USPQ 91 (PO BdPatApp 1971); *In re Scheckler* 168 USPQ 716 (CCPA 1971); *In re Young* 159 USPQ 725 (CCPA 1968); *In re Lyons* 150 USPQ 741 (CCPA 1966).

Art Unit: 1763

Regarding applicants argument that no reference suggests the synergy brought from collaboration of the features (a), (b) and (c), it is stated that the synergy is brought by one of ordinary skill in the art from the combined teaching.

The test of obviousness is not whether features of the secondary reference may be bodily incorporated into the primary reference's structure, nor whether the claimed invention is expressly suggested in any one or all of the references, rather the test is what the combined teachings would have suggested to those of ordinary skill in the art." *Ex parte Martin* 215 USPQ 543, 544 (PO BdPatApp 1981).

Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Ram N. Kackar whose telephone number is 571 272 1436. The examiner can normally be reached on M-F 8:00 A.M to 5:P.M.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Parviz Hassanzadeh can be reached on 571 272 1435. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Art Unit: 1763

Ram Kackar

Examiner AU 1763

Page 6